

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#10  
3-31-03  
Mullen

Application Serial No. .... 10/075,193  
Filing Date ..... February 13, 2002  
Inventor ..... Shenlin Chen et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Huynh, Y.  
Attorney's Docket No. .... MI22-1927  
Title: Methods of Forming a Capacitor Structure

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References -See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

RECEIVED  
MAR 20 2003  
T.C. 2800 MAIL ROOM

Respectfully submitted,

Dated: March 12, 2003

By: Jennifer J. Taylor

Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711

03/19/2003 CV0111 00000013 10075193

01 FC:1806

180.00 0P